



2813
JUL 29 2003

In re Application of:

KIYOFUMI SAKAGUCHI, ET AL.

Application No.: 10/085,046

Filed: March 1, 2002

For: PROCESS FOR PRODUCTION OF
SEMICONDUCTOR SUBSTRATE

Docket No. 03500.010530.5

Examiner:

Group Art Unit: 2813

Date: July 28, 2003

Mail Stop Interference
Director of the U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

TELETYPE NO. 201-1205
JUL 29 2003

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	159	MINUS	142	= 17	x \$9 \$18	\$306.00
INDEP. CLAIMS	33	MINUS	25	= 8	x \$42 \$84	\$672.00
Fee for Multiple Dependent claims \$140°/\$280						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$978.00

Verified Statement claiming small entity status is enclosed, if not filed previously.

A check in the amount of \$ 978.00 is enclosed.

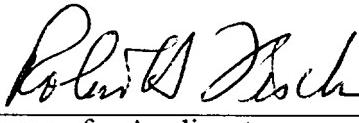
Charge \$ _____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under

37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

- A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.
- A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Registration No. 30,051

FITZPATRICK, CELLA, HARPER & SCINTO
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Form #120

NY_MAIN 365659v1

03500.010530.5



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
KIYOFUMI SAKAGUCHI, ET AL.) : Examiner:
Application Serial No.: 10/085,046) : Group Art United: 2813
Filed: March 1, 2002) :
For: PROCESS FOR PRODUCTION OF) :
SEMICONDUCTOR SUBSTRATE) :
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FOURTH PRELIMINARY AMENDMENT

Sir:

Prior to action on the merits, please further amend the above-identified application as follows:

IN THE CLAIMS:

Please add new claims 143-159, as follows:

143. (New) A method for making a thin film semi-conductor comprising the steps of:

providing a semi-conductor substrate having a surface;

07/30/2003 005MAH1 00000057 10085046

01 FG:1201
02 FG:1201

572.00 0P
305.00 0P